Appl. No. : 10/810,660 Filed : March 29, 2004

SUMMARY OF INTERVIEW

The Applicants wish to thank the Examiner for the helpful telephonic interview conducted on January 17, 2006. Present were Examiner Jarrett Stark and Applicant's attorney Ryan Melnick. The limitation in Claim 1 that the conductor layer is susceptible to etching by an etchant suitable to remove the sacrificial layer was discussed. Examiner Stark indicated that this phrase was not being given patentable weight. Applicant's attorney proposed including specific materials for the sacrificial layer into Claim 1 from dependent Claim 2. Examiner Stark indicated that if the materials were different from those disclosed in Miles (U.S. Patent No. 5,835,255) and there were functional differences between Miles and the claimed invention, then the claims would be allowable.